- <del>*</del>	Application No. Applicant(s)		
Notice of Allowability	10/827,470	KAMEI ET AL.	
	Examiner	Art Unit	
	Manish S. Shah	2853	And
The MAILING DATE of this communication apperall claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Re	(OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is su	this application. If not include nication will be mailed in due	ed course. <b>THIS</b>
1. $\boxtimes$ This communication is responsive to <u>Preliminary Amendment</u>	ent Submitted on 04/20/2004		
2. 🖾 The allowed claim(s) is/are 12-20.			
3. A The drawings filed on 20 April 2004 are accepted by the Ex	aminer.		
<ul> <li>4.</li></ul>	been received. been received in Application cuments have been received of this communication to file ENT of this application.  Itted. Note the attached EXA is reason(s) why the oath or it be submitted. On's Patent Drawing Review Amendment / Comment or it be submitted. SAMENDER AMENDE OF THE STATE OF THE	in No. 10/242,665.  In this national stage applicate a reply complying with the recommendate of the complying with the complying with the complying with the recommendate of t	quirements OTICE OF
Attachment(s)  1. ☑ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 4/20/2004  4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview Su Paper No./I 8), 7. ☐ Examiner's	ormal Patent Application (PTC) mmary (PTO-413), Mail Date Amendment/Comment Statement of Reasons for Allo	wance

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## **DETAILED ACTION**

## Allowable Subject Matter

The following is an examiner's statement of reasons for allowance:

1. The primary reason for allowance of claims 12-20 is that applicant's claimed invention includes a method of manufacturing an liquid jetting head including the steps of bonding the second substrate onto the first surface of the first substrate with an adhesive agent, while forming a coating layer comprised of a resin material on an inner wall face of a region at which the first through hole and the second through hole are to be connected; and forming a communicating portion at which the first through hole and the second through hole are connected. It is this limitation, expressed in the claimed combination not found, taught or suggested in the prior art, that makes these claims allowable over the prior art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Pertinent Prior Art

2. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

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(1) Takahashi (# JP 2000-103059) discloses the method for manufacturing of print head including a piezoelectric element formed in a pressure generating chamber; an adhesive layer formed in a corner part formed of the elastic membrane and faces constituting the peripheral wall of the pressure generating chamber (see Abstract).

(2) Murai (# US 2003/0058310) discloses a liquid head having passage forming substrate on which a pressure generating chamber communicating with a nozzle orifice formed, a plurality of piezoelectric elements are on one side of the passage forming substrate, and a penetrated portion for supplying a liquid to the communicating path is formed in a region of the vibration plate opposite to the communicating path by laser processing (see Abstract; figure: 2B).

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Manish S. Shah whose telephone number is (571) 272-2152. The examiner can normally be reached on 7:00am-3:30pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Stephen D. Meier can be reached on (571) 272-2149. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have guestions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Manish S. Shah Examiner Art Unit 2853

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